SBW Removal Profile — User Manual

App type: Streamlit

Common Tasks

A. View PRE or POST wafer profiles

- 1. Upload a PRE or POST .sbw file.
- 2. Select Thickness or Flatness from the dropdown menu.
- 3. Select **PRE** or **POST** in the segmented control.
- 4. Select one or more **Slots** from the multiselect dropdown menu. If multiple slots are selected, the plots are displayed in order.
- 5. (Optional) Check Mask notch in the sidebar to mask notch and filter out outlier values.
- 6. Click Plot.

B. View REMOVAL wafer profile

- 1. Upload both PRE and POST .sbw files.
- 2. Select Thickness or Flatness from the dropdown menu.
- 3. Select **REMOVAL** in the segmented control.
- 4. Select PRE slots and POST slots. If counts differ, the slots are paired in order.
- 5. (Optional) Check Overlay line charts in the sidebar to show PRE/POST on top of REMOVAL line charts.
- 6. Click Plot.

C. View average wafer profiles

- 1. Check Average Profile.
- 2. In PRE/POST profile mode: plots the average radial profile for the selected profile mode.
- 3. In REMOVAL profile mode: plots the average removal profile.

User Interface

Top controls

- Upload PRE .sbw | Upload POST .sbw: load .sbw files.
- Thickness | Flatness dropdown menu: select graph mode.
- PRE | POST | REMOVAL segmented control: select profile mode.
- Average Profile checkbox: switch to average profile mode.

Sidebar — Display controls

- Color clip low (%): slide to set the lowest percentile used for color range to prevent notch (outlier values) from skewing colors (default 0.5).
- Color clip high (%): slide to set the highest percentile used for color range (default 100).
- Mask notch: replaces notch (outlier values) (beyond $k \times MAD$, default k = 4) with NaN to prevent notch from skewing colors.
- (REMOVAL only) Overlay line charts: overlays PRE/POST lines on removal line plots.

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Angle selection

• Angle slider: slide to select an angle for a single-angle line chart.

The angle and direction at which the wafer has been line-scanned is indicated by the arrow shown on the icon of a wafer on top right of the chart.

Controls and interactions

- **Hover**: shows x/y/z values.
- Pan/Zoom: use mouse to drag/scroll in plots.
- Turnable rotation: use mouse to drag and turn the surfaces.
- (REMOVAL only) DI button: to switch between 2D and 3D plots for PRE and POST.

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